

Receipt date: 09/01/2006



IFW 5555855-1795

Attorney Docket No.: P/2850-120

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Toshinori Ota et al.

Date: August 29, 2006

Serial No.: 10/555,855

Group Art Unit: 1753

Filed: November 7, 2005

Examiner: ---

For: THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC
SEMICONDUCTOR ELEMENT USING THERMOELECTRIC SEMICONDUCTOR
MATERIAL, THERMOELECTRIC MODULE USING THERMOELECTRIC
SEMICONDUCTOR ELEMENT AND MANUFACTURING METHOD FOR SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of art together with a form listing the same
for the convenience of the Examiner.

I hereby certify that this correspondence is being
deposited with the United States Postal Service as
first class mail in an envelope addressed to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on August 29, 2006

Respectfully submitted,

Robert C. Faber

Name of applicant, assignee or
Registered Representative

Signature

August 29, 2006

Date of Signature

Robert C. Faber
Registration No.: 24,322
OSTROLENK, FABER, GERB & SOFFEN, LLP
1180 Avenue of the Americas
New York, New York 10036-8403
Telephone: (212) 382-0700

RCF:bar
Enclosures

SEP 01 2006

**APPLICANT'S ART
CITATION**

(Use several sheets if necessary)

Application 10/555,855

OFGS File No. P/2850-120

Applicant Toshinori OTA et al.

Filing Date November 7, 2005

Group Art Unit 1753

U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

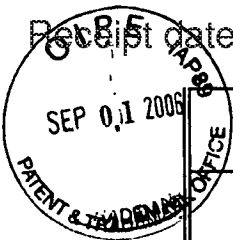
Exami ner Initial	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate
	US-4,764,212	08-1988	Okumura			
	US-6,274,802 B1	08-2001	Fukuda et al.			
	US-6,313,392 B1	11-2001	Sato et al.			
	US-6,319,744 B1	11-2001	Hoon et al.			

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation	
						Yes	No
	JP 05-335628	12-1993	Japan			X	
	JP 08-199281	08-1996	Japan			X	
	JP 10-117021	05-1998	Japan			X	
	JP 10/178218	06-1998	Japan			X	
	JP 10-178219	06-1998	Japan			X	
	JP 11-163422	06-1999	Japan			X	
	JP 11-261119	09-1999	Japan			X	
	JP 63-138789	06-1988	Japan			X	
	JP 2000-036627	02-2000	Japan			X	
	JP 2000-124512	04-2000	Japan			X	
	JP 2000-286471	10-2000	Japan			X	
	JP 2000-332307	11-2000	Japan			X	
	JP 2000-357821	12-2000	Japan			X	
	JP 2001-053344	12-2001	Japan			X	
	JP 2001-160633	02-2001	Japan			X	
	JP 2001-34587	12-2001	Japan			X	
	JP 2002-111086	04-2002	Japan			X	
	JP 2002-118299	04-2002	Japan			X	
	JP 2002-151751	05-2002	Japan			X	
	JP 2003-37302	02-2003	Japan			X	
	WO98/11612	03-1998	WIPO				

Receipt date: 09/01/2006

10555855 - GAU: 1795



OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Hiroshi Kato and Keiji Yoshikawa, " <i>Elastic Constants of Al-Cu Alloys Containing Columinar Crystals</i> " April 1981, Journal of the Sociey of Materials Science, Volume 30, No 331.
Examiner /Golam Mowla/	Date Considered 02/23/2010
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	